

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

Jian Zhou, Hua Chu

Assignee:

Nanometrics Incorporated

Title:

Method for Automatically De-Skewing of Multiple Layer Wafer for

Improved Pattern Recognition

Serial No.:

09/974,721

Filing Date:

October 9, 2001

Examiner:

Kevin Siangchin

Group Art Unit:

1765

Docket No.:

NAN050 US

Confirmation No.:

7841

Santa Clara, California December 20, 2004

MS AMENDMENT COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In Response to the Office Action dated December 8, 2004, Applicants elect without traverse to have the invention of Group I, Claims 1-8, 9-16 and 22, examined. Please withdraw from consideration Claims 17 and 23, which are drawn to the invention of Group II and Claims 18-21, which are drawn to the invention of Group III. Applicants reserve the right to seek examination of the invention of Groups II and III in a divisional application.

It is believed that no fees are due. Nevertheless, if the Patent Office determines that an extension and/or other relief is required, Patent Owner petitions for any required relief including extensions of time and authorizes the Commissioner to charge the cost of such petitions and/or other fees due in connection with this filing of this document to <u>Deposit</u>

<u>Account No. 50-2263</u> referencing M-11928 US.

Should the Examiner have any questions concerning this response, the Examiner is invited to call the undersigned at (408) 982-8200, ext. 2.

Via Express Mail Label No. EV 450 194 384 US

Respectfully submitted

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U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE s sign (+) inside this box ™ the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. 09/974,721 Application Number TRANSMITTAL October 9, 2001 **Filing Date FORM** Jian Zhou **First Inventor** 7841 Confirmation No. **Group Art Unit** 1765 (to be used for all correspondence after initial filing) Kevin Siangchin **Examiner Name** Total Number Of Pages In This Submission NAN050 US Attorney Docket No. **ENCLOSURES** (check all that apply) Fee Transmittal Form Assignment Papers After Allowance Communication to (1 page in duplicate) (for an Application) Fee Attached -- Credit Appeal Communication to Board of Drawing(s) Card Payment Form (1 pg) Appeals and Interferences Response to Restriction Requirement Appeal Communication to Group Licensing-related Papers (1 page) (Appeal Notice, Brief, Reply Brief) After Final Petition Proprietary Information Petition to Convert to a Affidavits/declarations Status Letter **Provisional Application** Power of Attorney, Revocation of Other Enclosure(s) (please identify Previous Powers; And Statement Extension of Time Request below): Under 37 CFR 3.73(b) Terminal Disclaimer RETURN RECEIPT POSTCARD **Express Abandonment Request** Request for Refund Information Disclosure Statement CD, Number of CD(s) Certified Copy of Priority Document(s) Remarks This is a Response to Missing Parts/ Incomplete Application under 37 CFR 1.52 or 1.53 Copy of Notice To File Missing Parts (2 pages) SIGNATURE OF APPLICANT, ATTORNEY OR AGENT Firm Michael J. Halbert (Reg. No. 40,633) Silicon Valley Patent Group LLP Individual Name 2350 Mission College Boulevard, Suite 360

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Signature

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